

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: : METHOD OF DETECTING  
: CHEMICAL MECHANICAL  
SETHURAMAN JAYASHANKAR ET AL. : POLISHING ENDPOINTS IN  
: THIN FILM HEAD PROCESSES  
: :  
: Attorney Docket No. SEAG 63336

**INFORMATION DISCLOSURE STATEMENT**

June 25, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Pursuant to the provisions of 37 CFR Sections 1.56, 1.97 and 1.98,  
Applicants submit herewith copies of the references cited on the attached Form  
PTO/SB/08A for consideration during prosecution of this application.

This Statement is filed solely for the purpose of complying with the  
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Respectfully submitted,

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				Application Number	
				Filing Date	
				First Named Inventor	Sethuraman Jayashankar
				Group Art Unit	
				Examiner Name	
Sheet	1	of	1	Attorney Docket Number	SEAG 63336

U.S. PATENT DOCUMENTS						
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
		5,972,787		Boggs et al.	10-26-1999	
		5,985,679		Berman	11-16-1999	
		6,117,777		Zhou et al.	09-12-2000	
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		6,537,133		Birang et al.	03-25-2003	
		Publication No. 2003/0045100		Saka et al.	03-06-2003	

FOREIGN PATENT DOCUMENTS								
Examiner Initials <sup>1</sup>	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
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